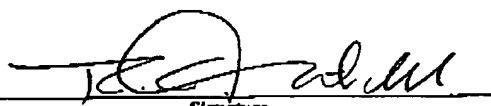



RECEIVED
CENTRAL FAX CENTER

OCT 14 2005

MAIL STOP AF

TRANSMITTAL LETTER (General Patent Pending)			Docket No. 10932-US
In Re Application Of: Luc OUELLET, et al.			
Serial No. 08/833,711	Filing Date 13 April 2001	Examiner. MARKHAM, Wesley	Group Art Unit 1762
Title: METHOD OF DEPOSITING OPTICAL QUALITY SILICA FILMS BY PECVD WHILE CONTROLLING GAS PRESSURE			
<p style="text-align: center;"><u>TO THE ASSISTANT COMMISSIONER FOR PATENTS:</u></p> <p>Transmitted herewith is:</p> <p style="text-align: center;">RESPONSE TO NOTICE OF NON-COMPLIANT AMENDMENT MAILED 09/29/2005 CERTIFICATE OF TRANSMISSION VBY FACSIMILE</p> <p>In the above identified application.</p> <p><input checked="" type="checkbox"/> No additional fee is required. <input type="checkbox"/> A check in the Amount of _____ is attached. <input type="checkbox"/> The assistant Commissioner is hereby authorized to charge and credit Deposit Account No. _____ as described below. A duplicate copy of this sheet is enclosed.</p> <p><input type="checkbox"/> Charge the amount of _____ <input type="checkbox"/> Credit any overpayment. <input type="checkbox"/> Charge any additional fee required.</p> <p style="text-align: center;"> Signature</p> <p>Dated: October 13, 2005</p> <p>Richard J. Mitchell 34,519</p> <p>Marks & Clerk Canada P.O. Box 957 Station B Ottawa, ON, K1P 5S7 Phone: (613) 236-9561</p> <p style="text-align: center;"> * 2 3 5 5 3 *</p> <div style="border: 1px solid black; padding: 5px;"><p>I certify that this document and fee being deposited on _____ with the U.S. Postal Service as first class mail under 37 C.F.R. 1.8 and addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231.</p><p>_____ Signature of Person Mailing Correspondence</p><p>_____ Typed or Printed Name of Person Mailing Correspondence</p></div>			

P16A/REV01

RECEIVED
CENTRAL FAX CENTER

OCT 14 2005

Appl. No. 09/833,711
Amdt. dated Oct 12, 2005
Reply to Notice of Sep 29, 2005

MAIL STOP AF

PATENT

Agent's Docket No. 10932-US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.	:	09/833,711	Confirmation No. 4962
Applicant	:	Luc OUELLET et al	
Filed	:	04/13/2001	
TC/A.U.	:	1762	
Examiner	:	MARKHAM, Wesley D.	
Docket No.	:	10932-US	
Customer No.	:	23553	

For: **METHOD OF DEPOSITING OPTICAL QUALITY SILICA FILMS
BY PECVD WHILE CONTROLLING GAS PRESSURE**

October 12, 2005

Mail Stop AF
Commissioner for Patents
Alexandria, VA
22313-1450

**RESPONSE TO NOTICE OF NON-COMPLIANT AMENDMENT MAILED
SEPTEMBER 29, 2005**

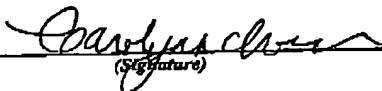
Sir:

In response to the Notice of Non-Compliant Amendment mailed September 29, 2005,
applicants are submitting herewith a replacement page 5 of the response.

RECEIVED
CENTRAL FAX CENTER

005

OCT 14 2005

CERTIFICATE OF TRANSMISSION BY FACSIMILE (37 CFR 1.8)			Docket No. 10932-US
Applicant(s): Luc OUELLET, et al.			
Serial No. 08/833,711	Filing Date 13 April 2001	Examiner MARKHAM, Wesley	Group Art Unit 1762
Invention: METHOD OF DEPOSITING OPTICAL QUALITY SILICA FILMS BY PECVD WHILE CONTROLLING GAS PRESSURE			
<p>I hereby certify that this <u>Response to Notice of Non-Compliant Amendment mailed September 29, 2005</u> (Identify type of correspondence) is being facsimile transmitted to the United States Patent and Trademarks Office (Fax No. <u>571-273-8300</u>) on <u>14 October 2005</u> (Date)</p> <p>Carolynn Irvin (Typed or Printed Name of Person Signing Certificate)</p> <p> (Signature)</p> <p>Note: Each paper must have its own certification of mailing.</p>			

P18/REV01